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PTO/SB/08b (08-03)

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Substitute for form 1449B/PTO

Application Number	10/688,797
Filing Date	October 17, 2003
First Named Inventor	Singh, et al.
Group Art Unit	160
Examiner Name	Unknown
Attorney Docket Number	AMAT/7729/TCG/EPI/LE
Submission Date	March 25, 2004

**SUPPLEMENTAL INFORMATION  
DISCLOSURE STATEMENT BY  
APPLICANT**

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RK	C1	IMAI, et al., "A Novel Atomic Layer Epitaxy Method of Silicon," Jpn. J. Appl. Phys. Vol. 30, No. 12B, December, 1991, pp. 3646-3651	
	C2		
	C3		
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	C7		
	C8		
	C9		
	C10		
	C11		
	C12		

Examiner

/Robert Kunemund/

Date Considered

06/06/2006

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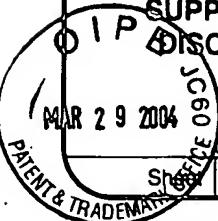
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